

AFTER FINAL - EXPEDITED PROCEDURE**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Takatoshi Tsujimura et al. § Art Unit: 1762
Serial No.: 10/693,244 §
Filed: October 24, 2003 §
For: Forming a Thin Film Structure § Atty. Dkt. No.: CMO.0012US (92096US)

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Commissioner for Patents
P.O. Box 1450
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REPLY TO OFFICE ACTION MAILED JANUARY 9, 2006

Dear Sir:

In response to the Office Action mailed January 9, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

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Date of Deposit: <u>March 9, 2006</u>
I hereby certify that this correspondence is being facsimile transmitted to the U.S. Patent Office (Fax No. (571) 273-8300) on the date indicated above.
<u>[Signature]</u> Ginger Yount